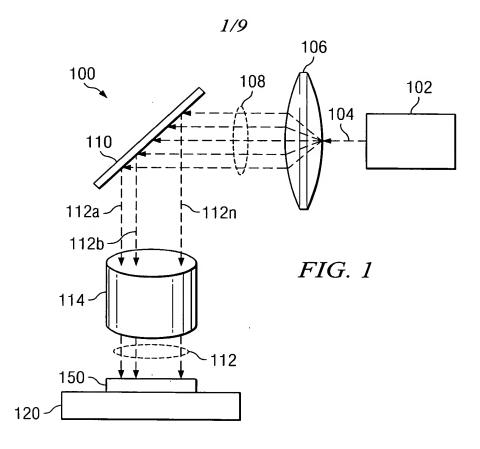
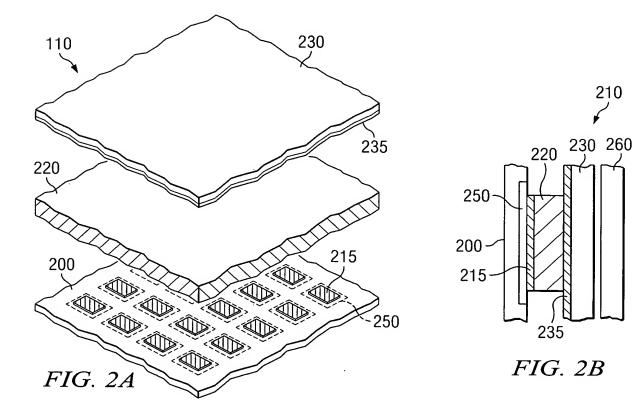
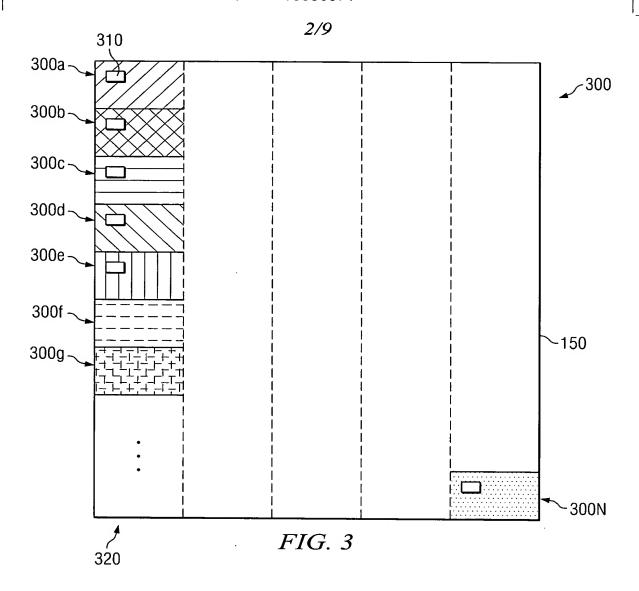
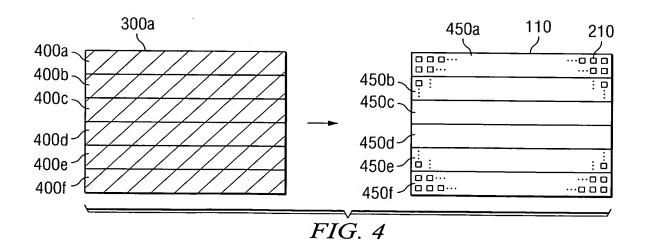
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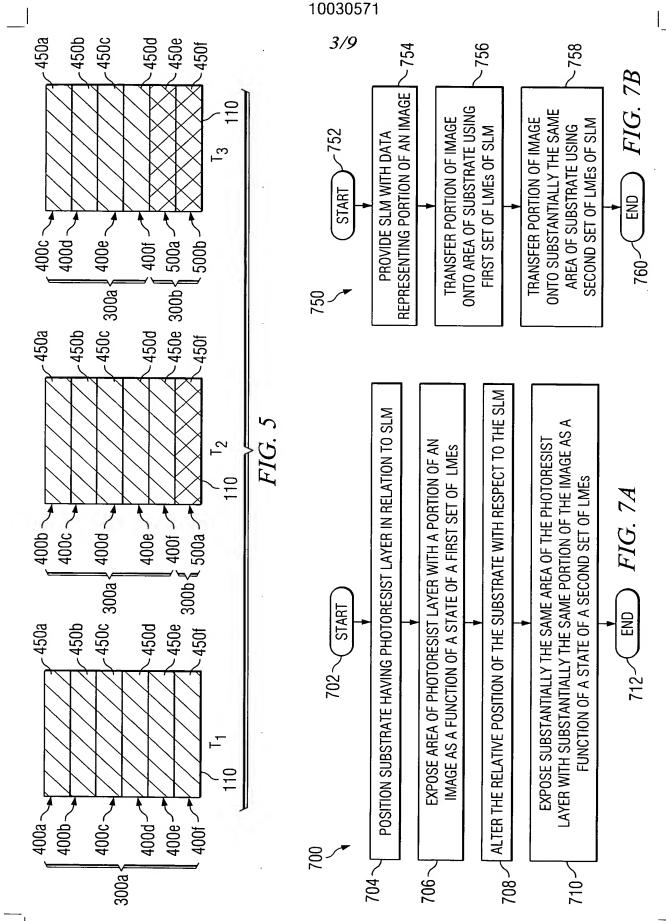


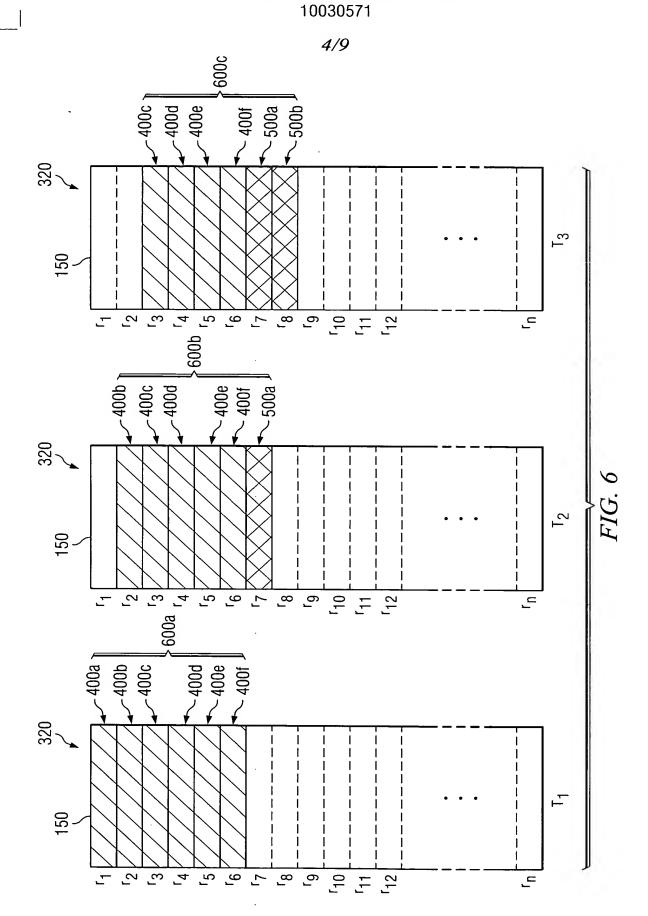


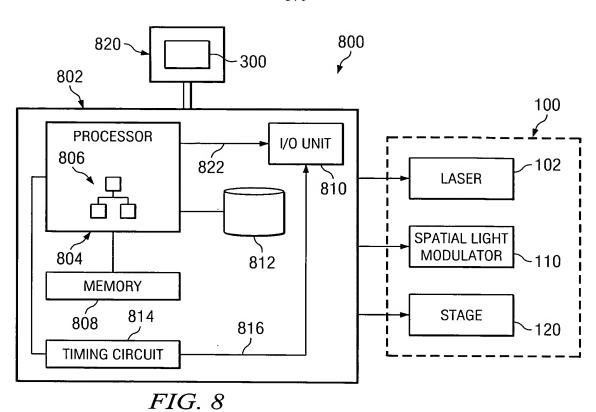
Spatial Light Modulator and Method for Performing Photolithography Ken A. Nishimura and Dale W. Schroeder 10030571

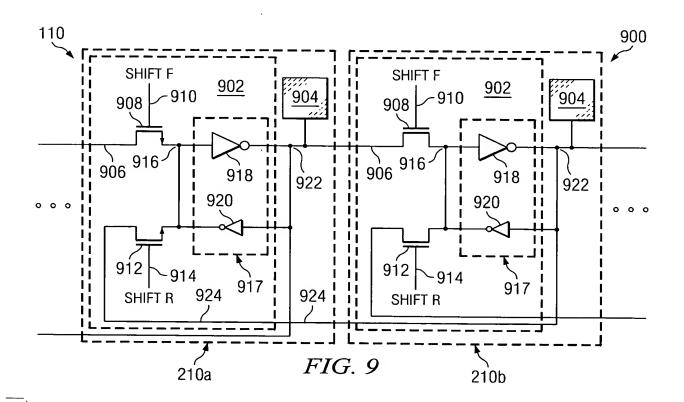




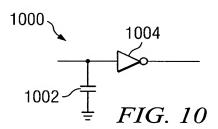


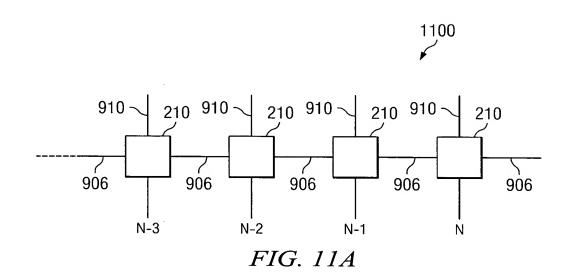


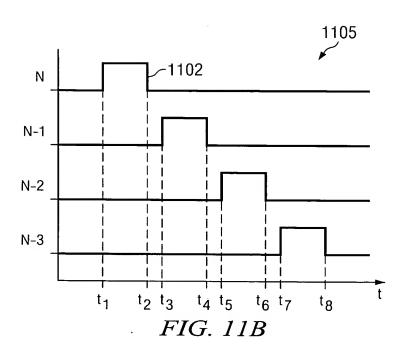


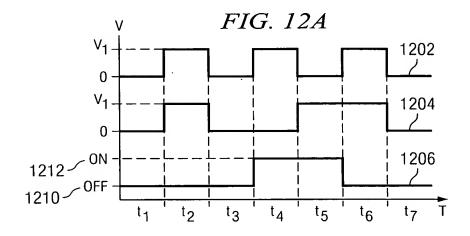


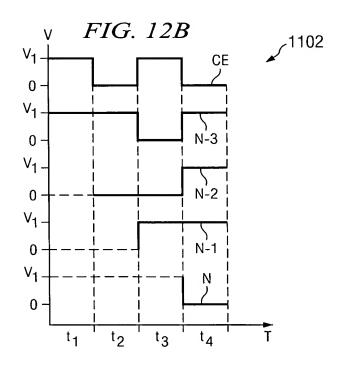
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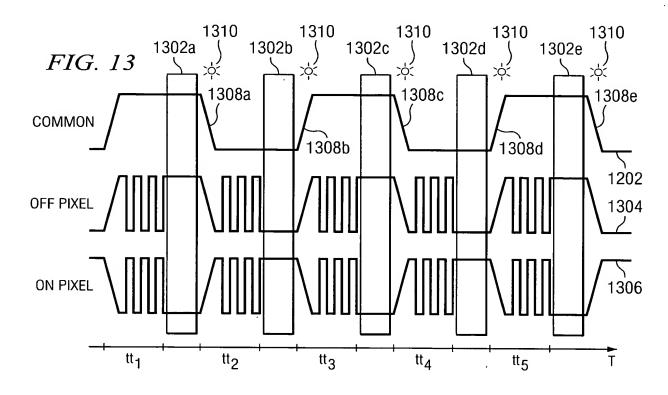


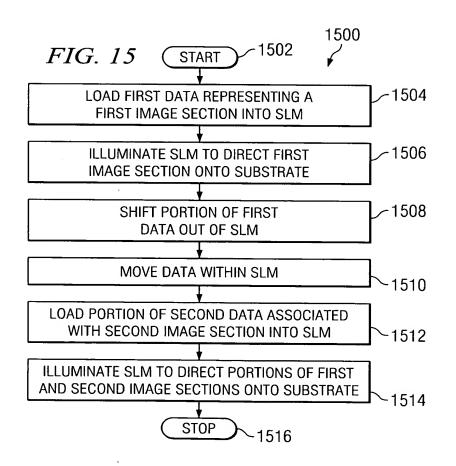






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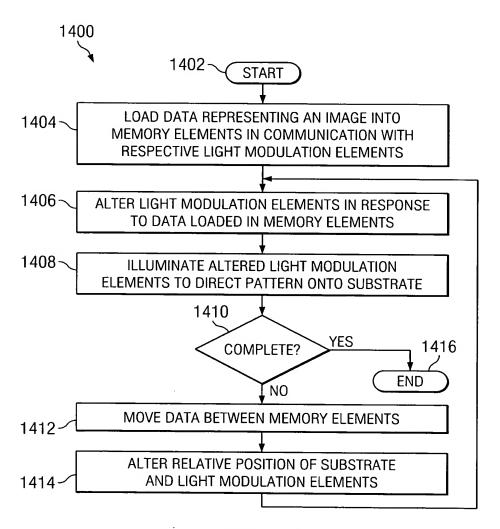


FIG. 14